

Applicant: Jae-Goo Lee and Cheol-Ju Yun  
Serial No. not yet assigned Examiner: not yet assigned  
Filing Date: October 29, 2003 Art unit: not yet assigned  
For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

**INFORMATION DISCLOSURE CITATION**  
**FORM PTO-1449 (Modified)**

**U.S. PATENT DOCUMENTS**

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Issue</u> <u>Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub</u> <u>Class</u>
_____	_____	US 6,458,692 B1	10/1/2002	Kim		

**FOREIGN PATENT DOCUMENTS**

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Publication</u> <u>Date</u>	<u>Country</u>	<u>Name</u>
_____	_____	2001-217405	10/8/2001	Japan	Yoshitaka, et al.

**OTHER DOCUMENTS**

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
_____	_____	English Language of Abstract from Japanese Patent Publication No. 2001-217405, published 10/8/2001.

Examiner: \_\_\_\_\_

Date Considered: \_\_\_\_\_